



**COPY**

*LNZ*

OSMM&N File No. 219289US0PCT

Dept.: IP-1

By: NFO/shb

Serial No. 10/069,943

In the matter of the Application of: Yasutaka ITO, et al.

For: CARBON-CONTAINING ALUMINUM NITRIDE SINTERED COMPACT  
AND CERAMIC SUBSTRATE FOR USE IN EQUIPMENT FOR  
MANUFACTURING OR INSPECTING SEMICONDUCTOR

Due Date: 03/10/04

The following has been received in the U.S. Patent Office on the date stamped hereon:

- ☐ Check for \$180.00
- ☐ Dep. Acct. Order Form
- ☐ Information Disclosure Statement
- ☐ PTO-1449
- ☐ Cited References (3)
- ☐ (4) JAPANESE Office Actions



OCT 12 2004

COPY

SHEET 1 OF 1

Form PTO 1449  
(Modified)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

SERIAL NO.

219289US0PCT

10/069,943

## LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Yasutaka ITO, et al.

FILING DATE

July 10, 2002

GROUP

1755

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AQ	11-355551	12/24/1999	JAPAN (with corr. JP 2001-140470)		X
	AP	2001-148476	05/29/2001	JAPAN	X	
	AQ	2-6367	01/10/1990	JAPAN	X	
	AR					
	AS					
	AT					
	AU					
	AV					

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW	
	AX	
	AY	
	AZ	

☐ Additional References sheet(s) attached

Examiner

Date Considered

6/8/04

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.